

<b>Notice of References Cited</b>	Application/Control No. 10/733,254	Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner Linh T. Nguyen	Art Unit 2627	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,611,383	08-2003	Lee, Hyoung Jae	359/629
*	B	US-5,309,423	05-1994	Noguchi et al.	369/110.04
*	C	US-2005/0163033	07-2005	Ichimura et al.	369/275.4
*	D	US-6,870,805	03-2005	Arai et al.	369/112.07
*	E	US-2003/0185136	10-2003	Kaiho et al.	369/112.22
*	F	US-6,256,272	07-2001	Yoon, Yong Han	369/44.23
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP-2002-100059	04-2002	Japan	Mogi Taketo	G11B 7/125
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.